



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al. Art Unit : 2811
Serial No. : 10/647,539 Examiner : Long Pham
Filed : August 26, 2003
Title : SEMICONDUCTOR THIN FILM AND ITS MANUFACTURING METHOD
AND SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO QUAYLE ACTION OF NOVEMBER 3, 2004

Please amend the above-identified application as follows:

Amendments to the claims begin at page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.